## INFORMATION DISCLOSURE CITATION

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Lockard, et al.		
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		U.S. PATEN	IT DOCUMENTS			.,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,	
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
/KAB/	4,552,784	11/12/1985	Chu, et al.	427	192		
/KAB/	5,126,529	06/30/1992	Weiss, et al.	219	121.6		
/KAB/	5,190,637	0302/1993	Guckel	205	118		
/KAB/	5,301,415	04/12/1994	Prinz, et al.	29	458		
/KAB/	5,555,481	09/10/1996	Rock, et al.	419	30		
/KAB/	5,718,863	02/17/1998	McHugh, et al.	264	309		
/KAB/	6,027,630	02/22/2000	Adam L. Cohen	205	135		
/KAB/	6,074,194	06/13/2000	McHugh	425	447		
/KAB/	6,096,381	08/1/2000	Zheng	427	454		
/KAB/	6,595,263	07/22/2003	Grinberg, et al.	164	46		
/KAB/	6,746,225	06/08/2004	McHugh	425	130	06/12/2000	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
/KAB/	Cohen, et al., "EFAB: Batch Production of Functional, Fully-Dense Metal Parts with Micron-Scale Features", Proc. 9th Solid Freeform Fabrication, The University of Texas at Austin, Aug. 1998, pp. 161.						
/KAB/		Adam L. Cohen, et al., "EFAB: Rapid, Low-Cost Desktop Micromachining of High Aspect Ratio True 3-D MEMS", Proc. 12th IEEE Micro Electro Mechanical Systems Workshop, IEEE, 17-21 Jan. 1999,					
/KAB/	"Microfabrication - Rapid Prototyping's Killer Application", Rapid Prototyping Report, CAD/CAM Publishing, Inc., Jun. 1999, pp. 1-5.						
/KAB/	Adam L. Cohen, "3-D Micromachining by Electrochemical Fabrication", Micromachine Devices, Mar. 1999, pp. 6-7.						
/KAB/	Gang Zhang, et al., "EFAB: Rapid Desktop Manufacturing of True 3-D Microstructures", Proc. 2nd International Conference on Integrated MicroNanotechnology for Space Applications, The Aerospace Co., Apr. 1999.						
/KAB/	F. Tseng, et al., "EFAB: High Aspect Ratio, Arbitrary 3-D Metal Microstructures Using a Low-Cost Automated Batch Process", 3rd International Workshop on High Aspect Ratio Microstructure Technology (HARMST'99), Jun. 1999.						
/KAB/	Adam L. Cohen, et al., "EFAB: Low-Cost, Automated Electrochemical Batch Fabrication of Arbitrary 3-D Microstructures", Micromachining and Microfabrication Process Technology, SPIE 1999  Symposium on Micromachining and Microfabrication, Sep. 1999.						
/KAB/	F. Tseng, et al., "EFAB: High Aspect Ratio, Arbitrary 3-D Metal Microstructures Using a Low-Cost Automated Batch Process", MEMS Symposium, ASME 1999 International Mechanical Engineering Congress and Exposition, Nov. 1999.						
/KAB/	/KAB/ Adam L. Cohen, "Electrochemical Fabrication (EFABTM)", Chapter 19 of the MEMS Handbook, edited by Mohamed Gad-EI-Hak, CRC Press, 2002, pp. 19/1 - 19/23.					andbook,	

/Katherine A. Bareford/	DATE CONSIDERED: 11/08/2007				
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